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BOX AF

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2612
Docket No.: 1186.1015

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kenzo FUKUYOSHI, et al.

Serial No. 09/768,454

Group Art Unit: 2612

Confirmation No. 3942

Filed: January 25, 2001

Examiner: Justin P. Misleh

For: A MICRO LENS ARRAY INCLUDING AN ETCHED DITCH AND TRANSPARENT
RESIN LAYER AND METHOD OF MANUFACTURING SAME (As Amended)

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Attention: **BOX AF**

Sir:

This is in response to the Office Action mailed December 23, 2004, and having a period
for response set to expire on March 23, 2005.

Reconsideration of the claims is respectfully requested. The following remarks are
respectfully submitted.

O.K. to Enter

Jan 4/1/05